

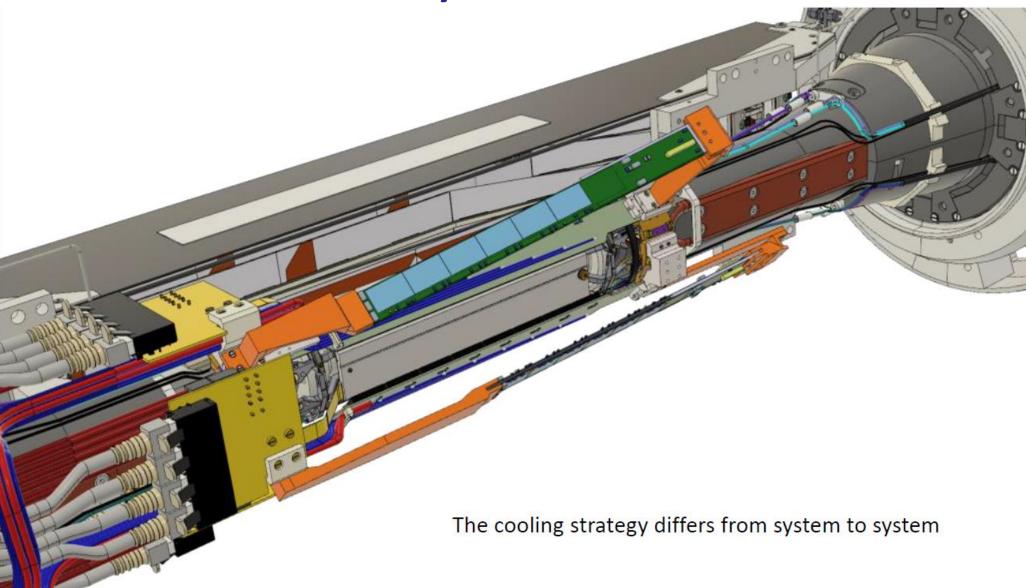
Phase 2 Thermal Management

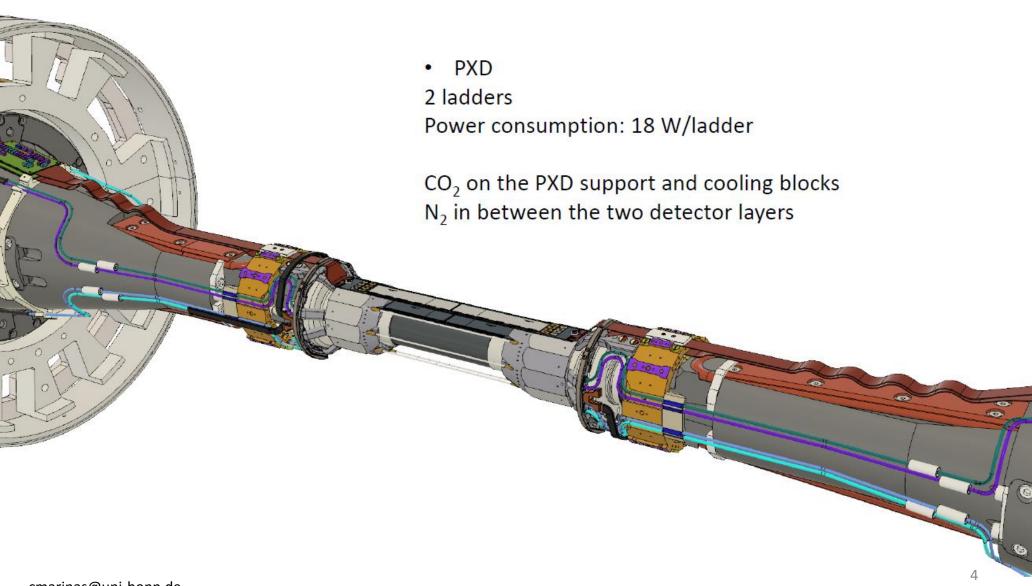
Sensor	Contact	Number	Location
Belle II PXD	C. Marinas	2 ladders	VXD
Belle II SVD	K. Nakamura	4 ladders	VXD
Diamond Sensors	L. Vitale	8 diamond s	VXD
FANGS	C. Marinas	3 arms 15 chips	VXD
CLAWS	F. Simon	2 ladders	VXD
PLUME	I. Ripp-Baudot	2 ladders	VXD
PIN diodes	H. Nakayama K. Nakamura	40+40	QCS
Micro-TPC	S. Vahsen	8 units	Dock
He-3	S. De Jong	4 units	Dock

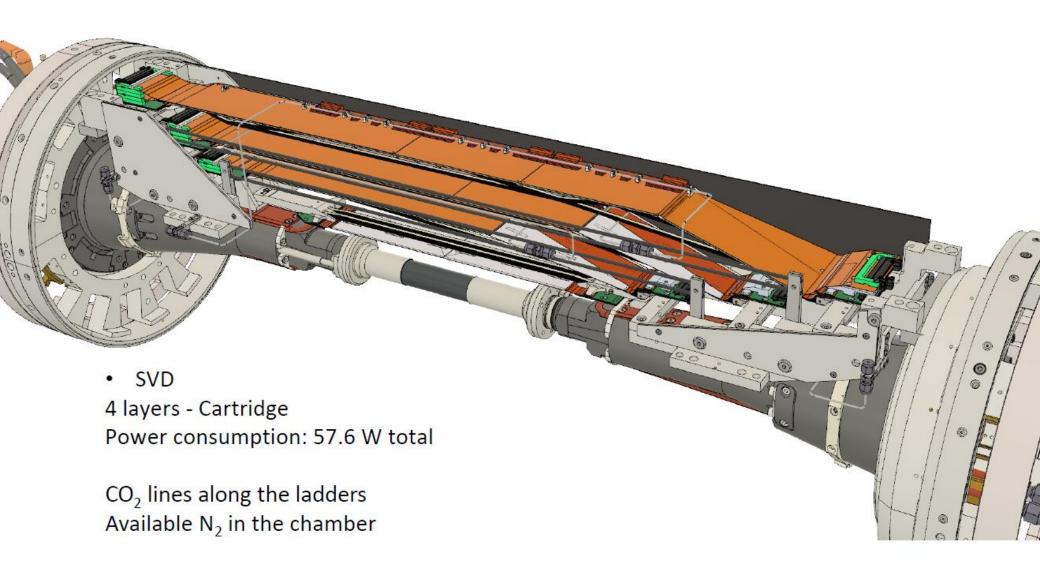


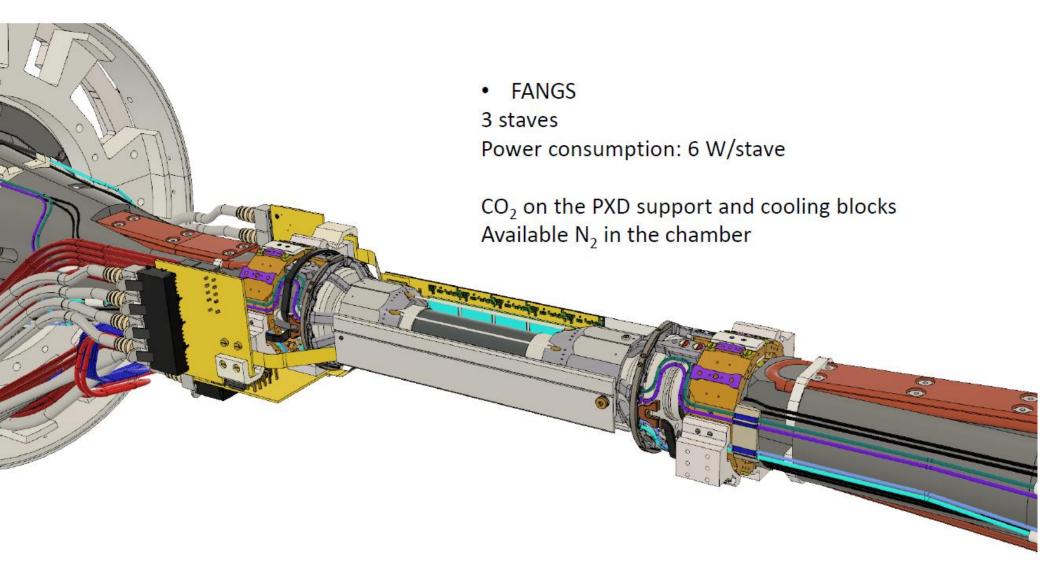
9+2 different technologies and detector systems

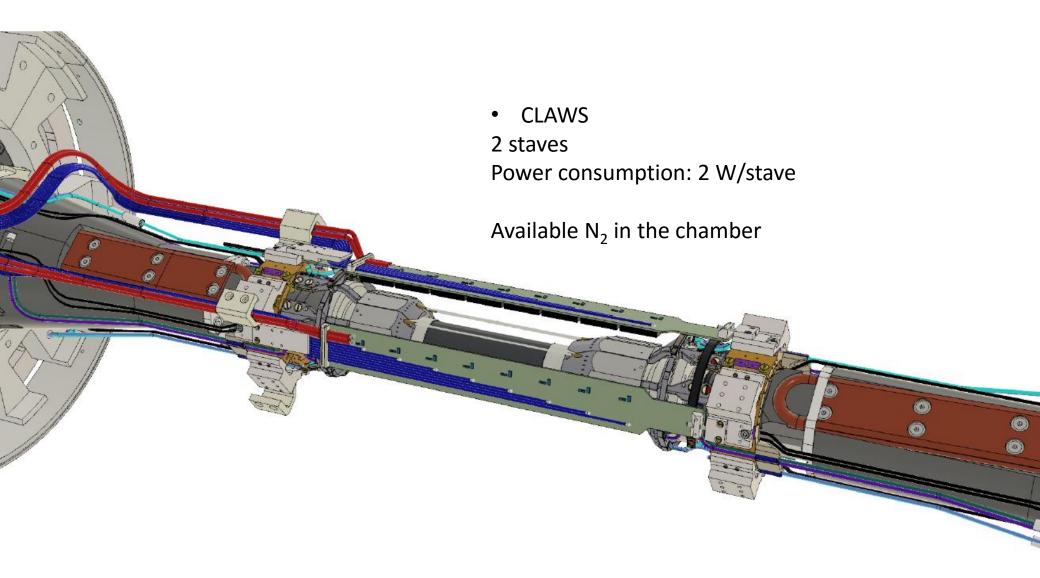
Sensor	Contact	Number	Location
FPGA**	R. Giordano	2 boards	SuperKEK pipe
LYSO- ECL**	A. Fodor	4+4 crystals	ECL endcap shield

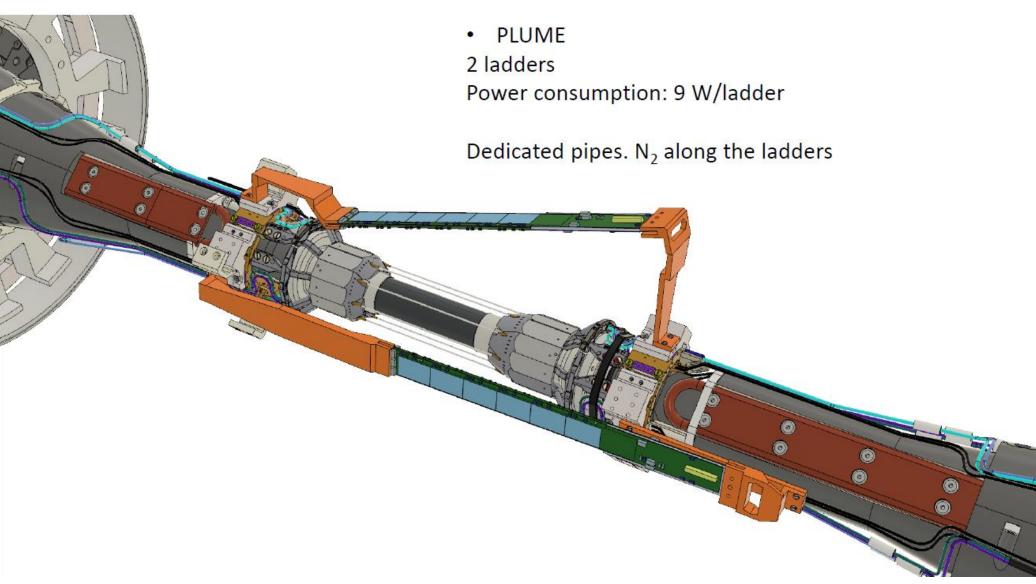












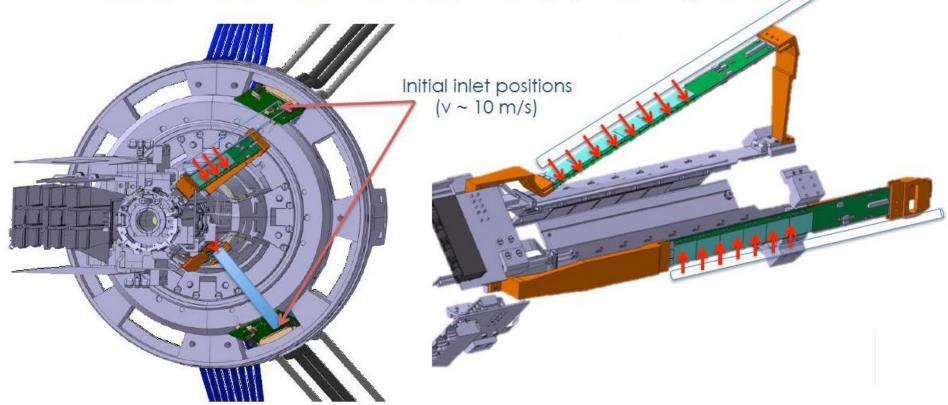
Proposed PLUME system



2 pipes required (in phase-3)

/ current phase-2

- Require one N₂ tube on each PLUME ladder
 - N_2 flow for each of this tube $Q_{PLUME} \sim 2$ to 4 L/min
 - Tubes run along PLUME and pinholes blow N₂ onto Si surface
 - Nb of holes & size adjusted to ensure velocity(N₂) v ~ 1.5 m/s
 - Total N_2 flow in the volume not thermally isolated from PLUME : $Q_{tot} \sim 40$ L/min



Open Questions

- Which is the temperature profile along CLAWS?
- Sufficiently low and flat temperature distribution?
- Dark rate vs temperature
- PLUME proposal acceptable?
- How many nitrogen lines are available (planned) in forward?
- Only way for testing: integration campaign with the hot PXD sensors in place
- Could the change in the fluid dynamics inside the VXD chamber compromise the PXD stability for Phase 2?



Thanks

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